In re Application of:

YASUHISA INAO, et al.

Application No.: 10/663,691

Filed: September 17, 2003

For: MASK, EXPOSURE APPARATUS,

AND EXPOSURE METHOD

Docket No. 00684.003542.

Examiner: J. S. Ruggles

Group Art Unit: 1756

Date: September 7, 2005

Mail Stop Amendment THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment and Response to Restriction Requirement in the above-identified application.

| X | No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	* 23	MINUS	** 23	0	x \$25 \$50	\$0	
INDEP. CLAIMS	* 5	MINUS	*** 5	= 0	x \$100 \$200	\$0	
Fee for Mu	\$0						
	\$0						

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
<u>`</u>	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Damond E. Vadnais

Damond E. Vadnais Attorney for Applicants Registration No.: 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

Form #120

CA_MAIN 101562v1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of:)	
YASUHISA INAO, et al.	:	Examiner: J. S. Ruggles
1 ASOTHSA IIVAO, Ct al.	;	Group Art Unit: 1756
Application No.: 10/663,691)	
Filed: September 17, 2003)	
For: MASK, EXPOSURE	;	
APPARATUS, AND	:	
EXPOSURE METHO)D)	September 7, 2005
Mail Stop Amendment		

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

$\frac{\text{AMENDMENT}}{\text{AND}}$ RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated August 9, 2005, please amend the above-referenced application as follows: